

ISSUE CLASSIFICATION	
Class	Subclass

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
hp SCANNED <u>Edm 3</u> O.A. <u>CML</u>	

APPLICATION NO. 09/816643	CONT/PRIOR F	CLASS A27/115	SUBCLASS 248.1	ART UNIT 1762	EXAMINER Hicks
------------------------------	-----------------	------------------	-------------------	------------------	-------------------

APPLICANTS

Seiyo Nakashima
Michiko Nishiwaki
Yukinori Aburatani
Satoshi Okada

Time

Substrate processing apparatus and substrate processing method

PTO-2040
12/89

ISSUING CLASSIFICATION									
ORIGINAL			CROSS REFERENCE(S)						
CLASS		SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)					
INTERNATIONAL CLASSIFICATION									

☐ Continued on Issue Slip Inside File Jacket

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner) (Date)		NOTICE OF ALLOWANCE MAILED	
	_____ (Primary Examiner) (Date)		ISSUE FEE	
Amount Due			Date Paid	
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent. No. _____ 	<input type="checkbox"/> The terminal ____ months of this patent have been disclaimed.		ISSUE BATCH NUMBER	
_____ (Legal Instruments Examiner) (Date)				

WARNING:
 The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.

Form **PTO-436A**
(Rev. 6/99)

FILED WITH: ☐ DISK (CRF) ☐ FICHE ☐ CD-ROM
(Attached in pocket on right inside flap)

(FACE)